

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	8061	(257/750,758,759,762,774).CQLS.	US-PGPUB; USPAT; EPO; DERWENT	OR	OFF	2008/01/04 14:18
L2	2435	L1 and (si silicon) adj substrate	US-PGPUB; USPAT; EPO; DERWENT	OR	OFF	2008/01/04 14:19
L3	1858	L2 and (dielectric passivation polymer)	US-PGPUB; USPAT; EPO; DERWENT	OR	OFF	2008/01/04 14:20
L4	278	L3 and ((si silicon) adj substrate) near5 (contact pad terminal)	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:21
L5	84	L4 and @ad<"19981221"	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:27
L6	1	L5 and "polymer layer"	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:28
L7	336310	(metalization interconnection "metal trace")	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:30
L8	30212	L7 and (si silicon) adj substrate	US-PGPUB; USPAT; EPO; DERWENT	OR	OFF	2008/01/04 14:30
L9	26855	L8 and (dielectric passivation insulation insulating polymer interlayer)	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:31
L10	3049	L9 and ((si silicon) adj substrate) near5 (contact pad terminal)	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:31
L13	537	L10 and ("polymer layer" polymer)	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:34
L14	150	L13 and @ad<"19981221"	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2008/01/04 14:34

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